



EFK

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76028

Yasuhiro IJIMA

Appln. No.: 10/628,459

Group Art Unit: 3765

Confirmation No.: 4842

Examiner: Hiteshaw, Felisa Carla

Filed: July 29, 2003

For: METHOD OF PRODUCING A POLYCRYSTALLINE THIN FILM AND A METHOD
OF PRODUCING AN OXIDE SUPERCONDUCTING ELEMENT

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 31, 2006, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE SPECIFICATION.....	2
AMENDMENTS TO THE CLAIMS	3
REMARKS	7